

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Confirmation No.: 8995

Makiko KITAZOE et al.

Group Art Unit: 1715

Application No.: 10/593,444

Examiner: Joseph Albert MILLER, Jr.

Filed: February 5, 2007

Attorney Docket No.: 029567-00011

For: UNIT-LAYER POST-PROCESSING CATALYST CHEMICAL-VAPOR-
DEPOSITION APPARATUS AND ITS FILM FORMING METHOD

**RESPONSE WITH FILING OF A REQUEST FOR
CONTINUED EXAMINATION (RCE) UNDER 37 C.F.R. § 1.114**

Mail Stop RCE

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

February 24, 2011

Sir:

This paper is submitted in reply to the outstanding Office Action dated August 24, 2010. The period for response is extended three months, from November 24, 2010, to February 24, 2011, with payment of the appropriate fees. Prior to continued examination of the above-identified application, please consider the amendments and remarks set forth on the following pages:

Amendments to the Claims begin on page 2.

Remarks begin on page 7.